

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor.....Luan C. Tran
AssigneeMicron Technology, Inc.
Group Art Unit2812
ExaminerS. Geyer
Attorney's Docket No.MI22-2357
Title: Methods of Forming Semiconductor Constructions

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

The attached Form PTO/SB/08a is submitted in compliance with 37 CFR §1.56. Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. No admission is made regarding whether the listed references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated:

July 19, 2007

By:

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